



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 2755

<b>SERIAL NUMBER</b> 10/081,180	<b>FILING DATE</b> 02/25/2002 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> 57810-032
<b>APPLICANTS</b> Masayuki Hata, Osaka, JAPAN; Tatsuya Kunisato, Osaka, JAPAN; Nobuhiko Hayashi, Osaka, JAPAN;				
<b>** CONTINUING DATA *****</b>  <b>** FOREIGN APPLICATIONS *****</b> JAPAN JP2001-51348 02/27/2001				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 04/22/2002</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	Examiner's Signature _____ Initials _____	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 14	<b>TOTAL CLAIMS</b> 22
<b>INDEPENDENT CLAIMS</b> 4				
<b>ADDRESS</b> McDERMOTT, WILL & EMERY 600 13th Street, N.W. Washington, DC 20005-3096				
<b>TITLE</b> Nitride-based semiconductor element and method of forming nitride-based semiconductor				
<b>FILING FEE RECEIVED</b> 860	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	